



LIST OF PUBLICATIONS CITED BY APPLICANT			Attorney Docket No. SEL 283		Serial No. Not Assigned	
			Applicant Estuko FUJIMOTO et al.			
			Filing Date October 24, 2001		Group 2818	
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
PP	JP 06-196494	07/15/94	Nakamura			12/22/92
PP	JP 2001- 210832	08/03/01				11/14/00
OTHER PUBLICATIONS (Including Author, Title, Date, Pertinent Pages)						
PP PP	1) JP 06-196494 full English translation. 2) JP 2001-210832 English abstract.					
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LIST OF PUBLICATIONS CITED BY APPLICANT	<u>Attorney Docket No.</u> SEL 283	<u>Serial No.</u> 10/017,114
	<u>Applicant</u> Estuko FUJIMOTO et al.	
	<u>Filing Date</u> October 24, 2001	<u>Group</u> 2818

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*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
PD	6,031,290	02/29/00	Miyazaki et al.	-	-	03/13/98

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PD	JP 06-148685	05/27/94	Nakazono et al.	-	-	11/13/92
PD	JP 07-235680	09/05/95	Goto et al.	-	-	02/24/94
PD	JP 08-274336	10/18/96	Uemoto et al.	-	-	03/30/95

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(Including Author, Title, Date, Pertinent Pages)

PD PD PD	1) JP 06-148685 English abstract. 2) JP 07-235680 English abstract. 3) JP 08-274336 English abstract.
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(Including Author, Title, Date, Pertinent Pages)

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- 1) U.S. Patent Application No. 09/433,705 (pending) including specification, claims, abstract and drawings.
- 2) U.S. Patent Application No. 09/436,984 (pending) including specification, claims, abstract and drawings.
- 3) U.S. Patent Application No. 09/447,574 (pending) including specification, claims, abstract and drawings.
- 4) U.S. Patent Application No. 09/464,200 (pending) including specification, claims, abstract and drawings.
- 5) U.S. Patent Application No. 09/471,359 (pending) including specification, claims, abstract and drawings.
- 6) U.S. Patent Application No. 09/714,891 (pending) including specification, claims, abstract and drawings.
- 7) U.S. Patent Application No. 09/432,662 (pending) including specification, claims, abstract and drawings.
- 8) U.S. Patent Application No. 09/435,154 (pending) including specification, claims, abstract and drawings.
- 9) U.S. Patent Application No. 09/441,025 (pending) including specification, claims, abstract and drawings.
- 10) U.S. Patent Application No. 09/454,146 (pending) including specification, claims, abstract and drawings.
- 11) U.S. Patent Application No. 09/618,930 (pending) including specification, claims, abstract and drawings.
- 12) U.S. Patent Application No. 09/619,732 (pending) including specification, claims, abstract and drawings.
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- 21) English abstract re Japanese Patent Application No. JP 2000-236097.
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- 24) English abstract re Japanese Patent Application No. JP 2001-094116.
- 25) English abstract re Japanese Patent Application No. JP 2001-111060.
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